

Imaye Rce / 1765

PATENT
Customer No. 22,852
Attorney Docket No. 07553.0020



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takeshi SAITO et al.) Group Art Unit: 1765
Application No.: 09/807,896) Examiner: S. Ahmed
Filed: April 19, 2001)
For: PLASMA ETCHING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a two-month extension of time to reply to the Office Action of September 24, 2003. A fee of \$420.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: 
Dustin T. Johnson
Reg. No. 47,684

Dated: February 23, 2004

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FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com